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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Patent Application of

IMAI ET AL.

Atty. Ref.: 1035-650

Serial No. 10/589,390

Group: 2812

Filed: August 15, 2006

Examiner: Unknown

For: Thin Film Transistor, Method of Manufacturing Same,
Display Device, Method Of Modifying An Oxide Film,
Method of Forming An Oxide Film, Semiconductor Device,
Method of Manufacturing Semiconductor Device, and
Apparatus For Manufacturing Semiconductor Device

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

STATUS INQUIRY

A national phase application was filed on August 15, 2006. However, since then applicant has not received the **Notice of Acceptance** and **Official Filing Receipt** from the Patent Office regarding the application. Inquiry is made as to when the **Notice of Acceptance** and **Official Filing Receipt** will be forthcoming. Please direct any response to this inquiry to Linda Hull at telephone number (703) 816-4127.

Respectfully submitted,
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January 11, 2007

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